

Notice of References Cited	Application/Control No. 09/293,536	Applicant(s)/Patent Under Reexamination PARLOS ET AL.	
	Examiner Elias Desta	Art Unit 2857	Page 1 of 1

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	K	US-			
	L	US-			
	M	US-			

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	W	Bulger, 'Stability Analysis of Laser Trimmed Thin Film Resistors', September 1975, IEEE Article, Vol. 11, No. 3, pages 172-177
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.